

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

James W. Adkisson et al.

Serial No. To be assigned

Filed: Herewith

For: STRUCTURE AND METHOD
FOR FORMATION OF A
BLOCKED SILICIDE RESISTOR

Art Unit: Unassigned

Examiner: Unassigned

Atty Docket: BU9-99-144

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

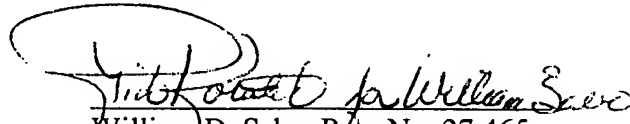
In compliance with the Applicants' duty of disclosure under 37 CFR § 1.56, the undersigned hereby submits the documents listed on the attached Form PTO-1449 for consideration by the Examiner in charge of the above-identified patent application.

It is believed that the documents identified do not disclose or make obvious a STRUCTURE AND METHOD FOR FORMATION OF A BLOCKED SILICIDE RESISTOR as claimed in the present application. Although the information disclosed above is that which the reviewing attorney or agent believes may be relevant based on a brief review of the application, the search report and the attached documents, the documents identified may contain relevant information other than that which has come to the attention of the reviewing attorney or agent. Accordingly, the Examiner is urged to review and form his or her own conclusions with regard to the relevance of the documents identified.

These documents are being submitted concurrently with the filing of the above-identified patent application and it is, therefore, believed no fee is due. However, the Commissioner is hereby

authorized to charge payment of any deficiency in the above fee(s) or to charge any additional fees required under 37 CFR § 1.16 or 1.17 or credit any overpayment to International Business Machines Corporation Deposit Account No. 09-0456.

Respectfully submitted,



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FORM PTO-1449

INFORMATION DISCLOSURE CITATIONAtty Docket
BU9-99-144Serial No.
To be assignedApplicant
James W. Adkisson et al.Filing Date
HerewithGroup Art Unit
To be assigned**U.S. PATENT DOCUMENTS**

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	5,780,331	07/14/98	Liaw et al.			
	AB	5,543,350	08/06/96	Chi et al.			
	AC	5,466,484	11/14/95	Spraggins et al.			
	AD	5,185,285	02/09/93	Hasaka			
	AE	5,013,677	05/07/91	Hozumi			
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation
	AO	EP 847077	06/10/98	EPO			Abstract
	AP						Yes No

OTHER (Including Author, Title, Date, Pertinent Pages, etc.)

	AR	
	AS	
	AT	

Examiner

Date Considered

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP § 609.

Draw line through citation if not in conformance and not considered.

Include copy of this form with next communication to Applicant.